

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date April 28, 2011

In re the Application of

Toru YAMADA

Application No.: 10/582,802

Filed: June 14, 2006

For: VAPOR PHASE GROWTH APPARATUS AND METHOD OF FABRICATING EPITAXIAL
WAFER



Group Art Unit: 1714

Examiner: M. SONG

Docket No.: 136170

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired April 24, 2011, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 237088 in the amount of \$130.00 in payment for:

 X Extension fee for response within first month pursuant to §1.136(a) (\$130.00)
 Extension fee for response within second month pursuant to §1.136(a) (\$490.00)
 Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1,110.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,

William P. Berridge
Registration No. 30,024

Aya Suzuki
Registration No. 64,621

WPB:AQS/sxl

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

04/29/2011 AWONDAF1 00000006 10502002

01 FC:1251

130.00 0P

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry of this filing;
Charge any fee due to our
Deposit Account No. 15-0461